

Notice of References Cited	Application/Control No. 09/838,684	Applicant(s)/Patent Under Reexamination WONG ET AL.	
	Examiner Vanessa Perez-Ramos	Art Unit 1765	Pag 1 of 1

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	C	US-5,660,624	08-1997	Dry, Carolyn M.	106/677
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NON-PATENT DOCUMENTS

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	U	Wolf, S. and Tauber, R.N., Silicon Processing for the VLSI Era, vol. 1, pp. 564-565
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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